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Dated: December 2, 2005

Signature: \_\_\_\_\_

(Marco Jimenez)

Docket No.: 199372002501

Client reference: 143150US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:  
Takayuki TOSHIMA et al.

Confirmation No.: 4004

Application No.: 10/606,135

Examiner: Joseph L. Perrin

Filed: June 25, 2003

Art Unit: 1746

For: SUBSTRATE PROCESSING APPARATUS  
FOR RESIST FILM REMOVAL  
(AS AMENDED)

AMENDMENT/SUBMISSION UNDER 37 C.F.R. § 1.114

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to a final Office Action dated June 2, 2005, for which a response was due on September 2, 2005, and for which a three-month extension of time is also requested to extend the time for response from September 2, 2005, to December 2, 2005, please amend the above-identified patent application as follows.

## **SUMMARY OF AMENDMENTS**

### **SPECIFICATION**

☒ There are amendments to the specification.

### **CLAIMS**

☐ There are no amendments to the claims.

☒ A complete listing of all claims ever present in this case in ascending order with status identifier is presented in a separate section.